

Notice of References Cited	Application/Control No. 10/677,164		Applicant(s)/Patent Under Reexamination GUTKOWSKI ET AL.	
	Examiner Jeffrey J. Chow		Art Unit 2672	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,093,653	03-1992	Ikehira, Kimimasa	345/657
*	B	US-5,233,168	08-1993	Kulik, George	235/456
*	C	US-5,355,420	10-1994	Bloomberg et al.	382/155
*	D	US-5,517,587	05-1996	Baker et al.	382/296
*	E	US-5,832,110	11-1998	Hull, Jonathan J.	382/168
*	F	US-6,038,349	03-2000	Cullen, John	382/294
*	G	US-6,430,320	08-2002	Jia et al.	382/289
*	H	US-6,738,154	05-2004	Venable, Dennis L.	358/1.15
*	I	US-6,898,316	05-2005	Zhou, Lingxiang	382/190
*	J	US-6,999,207	02-2006	Nakane, Naomi	358/474
*	K	US-2002/0028027	03-2002	Koyama, Toshiya	382/289
*	L	US-2002/0122067	09-2002	Geigel et al.	345/788
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.